



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 249/400

In re patent application of

Young-Jin CHO, et al.

Group Art Unit: 2815

Serial No. 10/634,841

Examiner: G.C. Eckert

Filed: August 6, 2003

For: BISMUTH TITANIUM SILICON OXIDE, BISMUTH TITANIUM SILICON OXIDE THIN FILM, AND METHOD FOR FORMING THE THIN FILM

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Sir:

In response to the Office Action dated November 24, 2004, applicants hereby elect the claims of Group I, claims 1, 2 and 19-22, for prosecution in the subject application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: December 27, 2004

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**PETITION and  
DEPOSIT ACCOUNT CHARGE AUTHORIZATION**

This document and any concurrently filed papers are believed to be timely. Should any extension of the term be required, applicant hereby petitions the Director for such extension and requests that any applicable petition fee be charged to Deposit Account No. 50-1645.

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the accompanying papers may also be charged to Deposit Account No. 50-1645.